



IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Mail Stop: ISSUE FEE**
Kenji SAWAMURA : **Confirmation No. 8571**
Serial No. 10/614,781 : [Group Art Unit 2815
Filed July 9, 2003 : Examiner Jesse A. Fenty]

SEMICONDUCTOR DEVICE
HAVING A DUMMY ACTIVE REGION
FOR CONTROLLING HIGH DENSITY
PLASMA CHEMICAL VAPOR DEPOSITION

AMENDMENT UNDER 37 CFR 1.312 AFTER
RECEIPT OF NOTICE OF ALLOWANCE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED
TO ACCEPT THE AMENDMENT IN THE
FEE RECEIPT NUMBER TO DEPOSIT
ACCOUNT NO. 23-0975

Sir:

Kindly amend the above-identified application as follows.